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\*\* CONTINUING DATA \*\*\*\*\*

NONE VY

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

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Verified and Acknowledged Examiner's Signature: <i>V. J. Kar</i> Initials: <i>VY</i>	JAPAN	7	11	3

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## TITLE

Organic insulating film forming method, semiconductor device manufacture method, and TFT substrate manufacture method

FILING FEE	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )
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